



500.36904X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: H. Miura, et al.

Application No.: 09/254,939

Filing Date: March 17, 1999

For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE HAVING  
TRENCH ELEMENT SEPARATION STRUCTURE

Art Unit: 2814

Examiner: Anh D. Mai

**SUBMISSION UNDER 37 CFR § 1.114  
(AMENDMENT)**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

November 3, 2003

Sir:

Concurrently with the filing of a Request for Continued Examination (RCE)

Transmittal in connection with the above-identified application, please amend the  
above-identified application, prior to further examination thereof, and in response to the  
Office Action mailed July 3, 2003, as listed in the following, and as set forth on the  
following pages:

~~Amendments to the Claims; and~~

Remarks are included following the amendments.

RECEIVED  
NOV - 7 2003  
TECHNOLOGY CENTER 2800

BEST AVAILABLE COPY